

FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO <b>35.C14055</b>		APPLICATION NO <b>09/413,774</b>	
				APPLICANT <b>NOBUHIRO ITO ET AL.</b>			
				FILING DATE <b>OCTOBER 7, 1999</b>		GROUP <b>2722</b>	

  

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
SR	4,904,895	2/90	Tsukamoto et al.	313	336	5/88	
SR	5,029,314	7/91	Katsumi et al.	355	208	6/90	
SR	5,066,883	11/91	Yoshioka et al.	313	309	7/88	
SR	5,523,834	6/96	Ito	355	315	10/92	
SR	5,729,802	3/98	Hirabayashi et al.	399	174	9/96	
SR	5,760,538	6/98	Mitsutake et al.	313	422	8/97	
SR	5,970,285	10/99	Ito et al.	399	149	4/97	
SR	5,995,786	11/99	Ito	399	150	3/98	

  

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO OR ABSTRACT	
SR	64-31332	2/89	Japan			Abstract	
SR	2-257551	10/90	Japan			Abstract	
SR	3-55738	3/91	Japan			Abstract	
SR	4-28137	1/92	Japan			Abstract	
SR	8-180821	7/96	Japan			Abstract	
SR	10-144203	5/98	Japan			Abstract	

  

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
	W. P. Dyke et al, "Field Emission", Advances in Electronics and Electron Physics, 1956. Vol. VIII, pp. 89-185.
	C. A. Mead, "Operation of Tunnel-Emission Devices", Journal of Applied Physics, April 1961, Vol. 32, No. 4, pp. 646-652.
	G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, 1972, pp. 317-328.
	M. Hartwell et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", IEDM Technical Digest, 1975, pp. 519-521.

  

EXAMINER <i>Sikha Roy</i>	DATE CONSIDERED <i>11/99</i>
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\*EXAMINER Initial reference considered whether or not citation is in performance with MPEP 609. Drawings through citation from a performance and not considered. Include cop. form with next communication to applicant.

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U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
SR	6,005,540	12/21/99	Shinjo et al.	345	74	10/7/97	

  

FOREIGN PATENT DOCUMENTS							
DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT		

  

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
SR	M. I. Elinson et al., "The Emission of Hot Electrons and the Field Emission of Electrons from Tin Oxide", Radio Engineering and Electronic Physics, July 1965, pp. 1290-1296.
SR	C. A. Spindt et al., "Physical Properties of Thin-Film Field Emission Cathodes with Molybdenum Cones", Journal of Applied Physics, December 1976, Vol. 47, No. 12, pp. 5248-5263.
SR	H. Araki et al., "Electroforming and Electron Emission of Carbon Thin Films", Journal of the Vacuum Society of Japan, January 1983, Vol. 26, No. 1, pp. 22-29.
SR	R. Meyer, "Recent Development on 'Microtips' Display at Leti", Technical Digest of IVMC 91, 1991, pp. 6-9.

Examiner's references cited were considered relevant to the invention. Applicant should show the foreign citations in their correspondence and not considered. Include copy form with next communication to applicant.

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